



AF/1763
ZFW

Attorney Docket No.: SEL 231

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
)
Yamazaki et al.)
)
Serial No.: 09/724,002)
)
Filed: November 28, 2000)
)
For: Film Deposition Apparatus And)
Method Of Manufacturing A Light)
Emitting Device Using The)
Apparatus)
)
Art Unit: 1763)
)
Examiner: K. Moore)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on <u>September 13 2006</u> (Date of Deposit)	
<u>Shannon Wallace</u> Name of applicant, assignee, or Registered Rep.	
<u>Shannon Wallace</u> Signature	<u>9/13/06</u> Date

Commissioner for Patents
P.O. Box 1450
Alexandra, VA 22313-1450

AMENDMENT H (AFTER FINAL)

Sir:

In response to the Final Rejection dated June 13, 2006, please enter the following amendment in the above-identified application: